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Accreditation & Standards

Our XPS analyses are accredited according to ISO/IEC 17025:2017.

The RMS Foundation's management system is certified to ISO 9001:2015.

In the standards ISO 10993-18 and ASTM F2847, XPS is expressly recommended for the *insitu* determination of the surface composition of medical devices—both for organic and inorganic substances as well as for insoluble particles.

ISO 9001 Quality management systems - Requirements

ISO/IEC 17025 General requirements for the competence of testing and calibration laboratories
ISO 10993-18 Biological evaluation of medical devices - Part 18: Chemical characterization of materials
ASTM F2847 Standard Practice for Reporting and Assessment of Residues on Single Use Implants

Sample requirements

Materials

Vacuum-compatible metals (including magnetic ones) and non-metallic solids as well as powders.

Dimensions

- Maximum sample diameter: 80 mm
- Maximum sample height: 20 mm
- Larger samples can be crushed if necessary

Condition upon Delivery

- Avoid touching the samples by hand whenever possible.
- For transport, wrap them dry in conventional aluminium foil.

Contacts

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Discuss your questions with us – we are happy to advise you. For more information, please visit <u>www.rms-foundation.ch</u>.

XPS Analysis



X-Ray Photoelectron Spectroscopy (XPS)

Chemical surface analysis for:

- Quality Control: Cleanliness
- Contaminants and residues
- Monitoring of surface modifications

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How does XPS work?

In an X-ray photoelectron spectrometer, electrons are excited by X-rays so strongly that they leave their atoms and ultimately exit the sample surface. The energy of these photoelectrons is measured and used to calculate their binding energy, enabling a qualitative and quantitative determination of the chemical composition in the top 5 to 10 nm of the surface.

With this technique, all elements except hydrogen and helium can be detected, and their binding states can be analysed. The detection limit is approximately 0.1 at%, corresponding to about 1 ng/cm² on the sample surface.

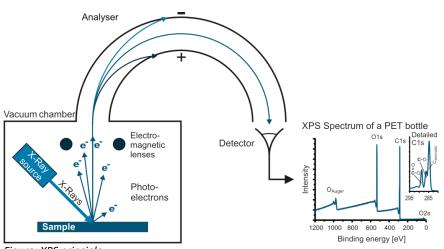


Figure: XPS principle.

Applications

XPS is a non-destructive technique used to analyse:

- The cleanliness of surfaces for quality control
- The chemical composition of contaminants and residues
- Chemical modification after surface treatments

XPS analyses serve customers in the medical technology sector as well as in other industries such as watchmaking, coatings, electronics, and semiconductors.

Equipment

PHI Genesis by Physical Electronics / ULVAC-PHI

This spectrometer is suitable for all standard analyses and is particularly notable for its ability to investigate micrometre-sized structures from $5 \mu m$.

Analysis Types & Costs

Depending on your needs, various types of analysis are available, all of which are accredited. In the basic package (XPS analysis incl. test certificate), high-resolution survey spectra are quantitatively evaluated. The option that includes a report allows for more detailed investigations. Special investigations such as measurements in very small areas, angle-resolved measurements, imaging XPS, or depth profiling are carried out in extended XPS analyses.

Table: XPS Analysis Types, and their Capabilities

TUDIE. AFS ATTUTY	sis Types, und their Capabilities			
Service		XPS-Analysis incl. Test Certificate	XPS-Analysis incl. Report	Extended XPS-Analysis
Measurement	High-resolution survey spectra ¹ Quantification of all detected elements	yes	yes	yes
	Detailed spectra¹ Additional analysis of chemical and oxidation states	-	yes	yes
Area of analysis	large: Ø 200 μm, scanning possible	yes	yes	yes
	small: Ø 50–100 μm	_	yes	yes
	very small: Ø 5–20 μm	_	-	yes
Detection limit	0.1–0.3 at%, depending on element	yes	Yes	yes
Uncertainty	15 % for main elements, up to 100 % for trace elements	yes	Yes	yes
Special analyses	angle-dependent analysis to analyse surface depth distributions	-	_	yes
	imaging-XPS to chemically map the surface	-	-	yes
	depth profile using Ar-sputtering	_	_	yes
Report	Test Certificate (German or English)	yes	-	yes
	Report (German or English)	_	yes	yes

In high-resolution survey spectra, the fwhm(Ag 3d_s/₂) is 0.8 to 1.0 eV, while in detailed spectra it ranges between 0.4 and 0.5 eV, depending on the pass energy.

Table: XPS Analysis Types, and associated Costs

Total Number of		Price/Spot in CHF	
Analysed Spots ²	XPS-Analysis incl.	XPS-Analysis	Extended
	Test Certificate	incl. Report	XPS-Analysis
1	450	600	
2	320	440	Prices
≥ 3	270	380	on
≥ 6	240	330	request
≥9	220	300	

Sum of all analysed spots in an investigation (for example, 3 samples × 2 spots per sample results in a total of 6 analysed spots).